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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2823
Examiner: Fernando L. Toledo

In Re PATENT APPLICATION of:

Applicant(s): Masaru TAKAISHI

Serial No.: 10/766,212

Filing Date: January 29, 2004

For: METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

Atty. Ref.: AI 325

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**PETITION FOR
ONE-MONTH
EXTENSION OF
TIME**

October 26, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the period for replying to the Examiner's Action mailed on June 30, 2006, be extended for one month under the provisions of 37 C.F.R. 1.136(a).

The applicable extension fee of \$120.00 pursuant to 37 C.F.R. 1.17(a) is submitted herewith.

Should this remittance be accidentally missing or insufficient, the Commissioner is hereby authorized to charge the fee to our Deposit Account No. 18-0002, and advise us accordingly.

Respectfully submitted,

October 26, 2006
Date

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